

High-Intensity High-Brightness Polarized and Un-polarized H- Beam production in Charge-exchange Collisions

A.Zelenski
Brookhaven National Laboratory

PAC 2011, New York

Workshop on high-energy spin physics, IHEP, Protvino, September 1983



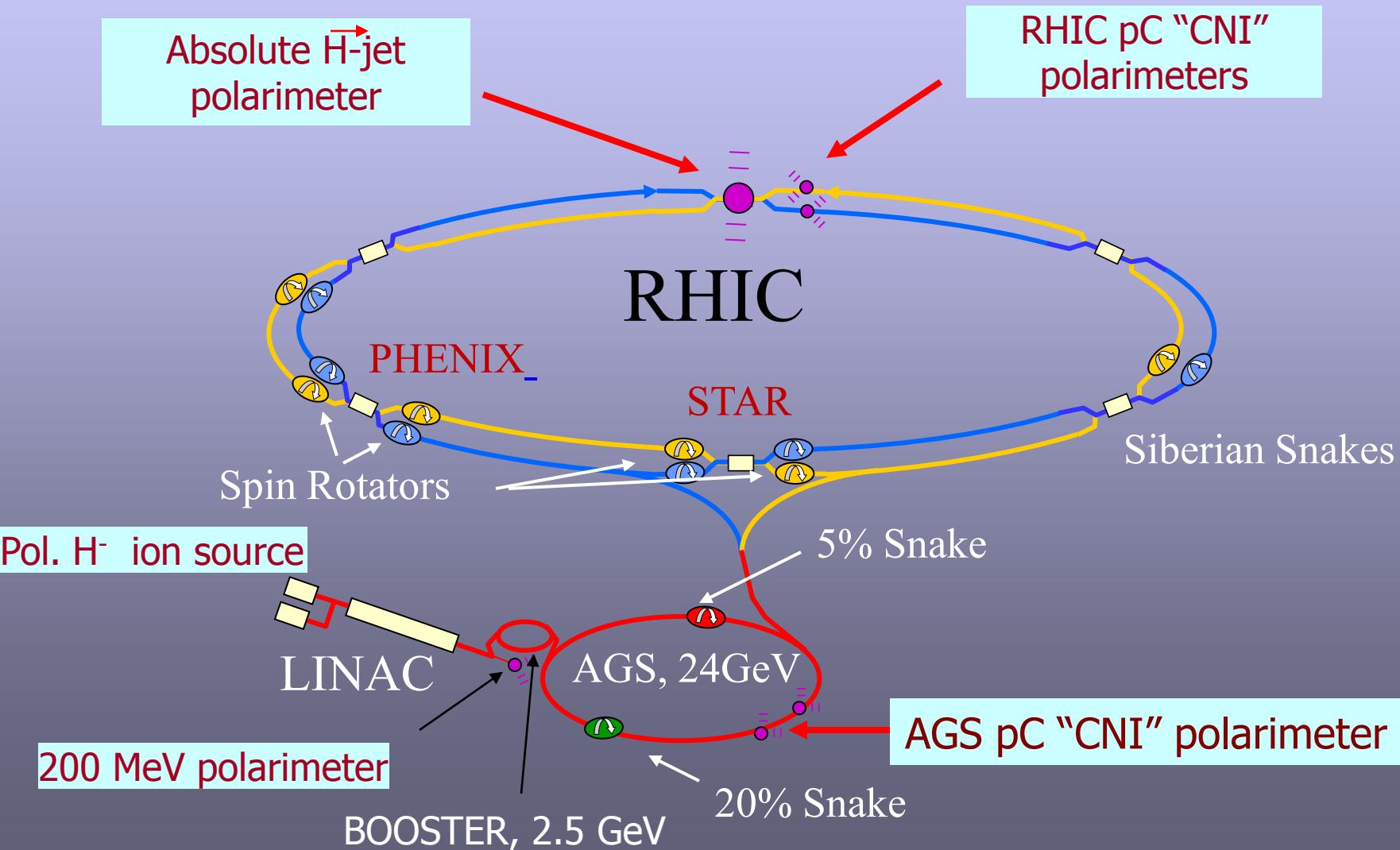
Yaroslav Derbenev
“Siberian snakes”



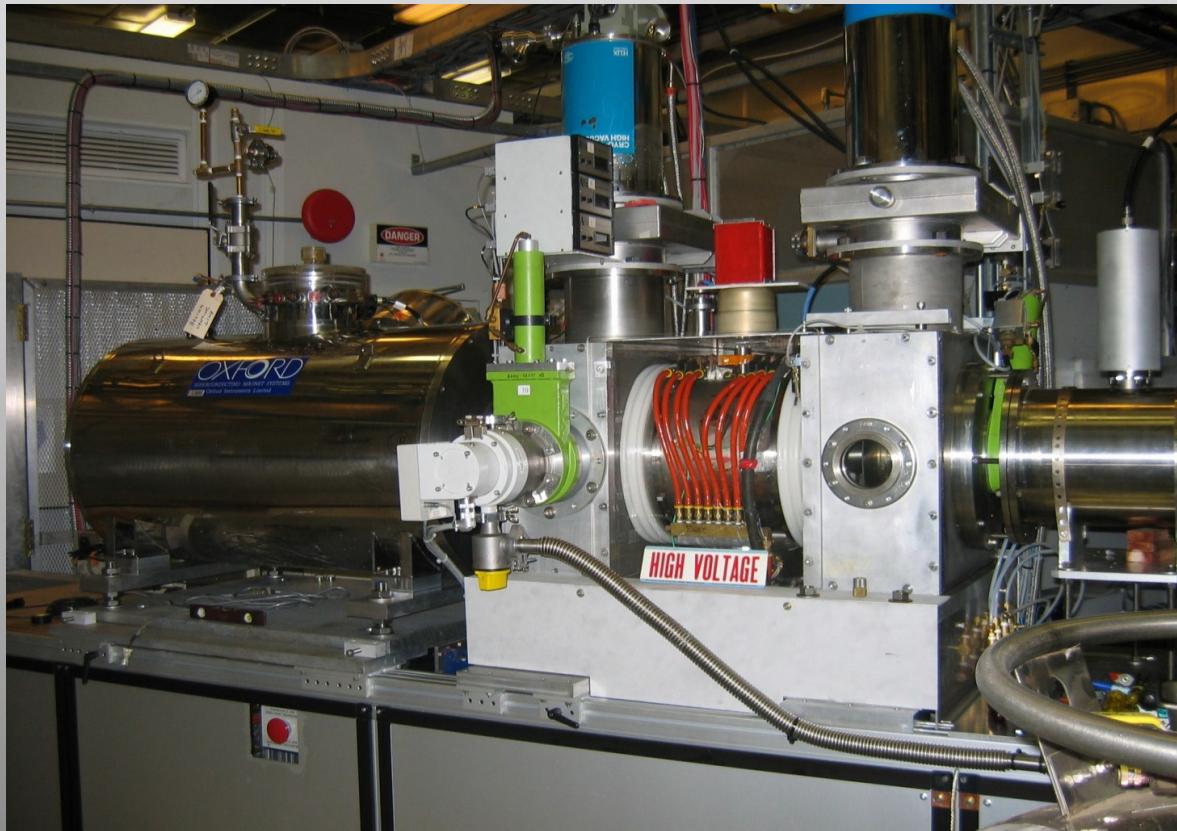
Anatoli Zelenski
A new polarization technique.
Equal intensity for polarized and
unpolarized proton beams.

Polarization facilities at RHIC.

Design goal: $P=70\%$, $L_{\max} = 1.6 \times 10^{32} \text{ s}^{-1}\text{cm}^{-2}$ $50 < \sqrt{s} < 500 \text{ GeV}$



Operational Polarized H⁻ Source at RHIC.



RHIC OPPIS produces reliably 0.5-1.0mA polarized H⁻ ion current. Polarization at 200 MeV: P = 80-85%.

Beam intensity (ion/pulse) routine operation:

Source	- 10^{12} H ⁻ /pulse
Linac	- $5 \cdot 10^{11}$
AGS	- $1.5 - 2.0 \cdot 10^{11}$
RHIC	- $1.5 \cdot 10^{11}$ (protons/bunch).

A 29.2 GHz ECR-type source is used for primary proton beam generation. The source was originally developed for dc operation. A ten-fold intensity increase was demonstrated in a pulsed operation by using a very high-brightness Fast Atomic Beam Source instead of the ECR proton source .

Polarized beams at RHIC.

OPPIS

$10 \cdot 10^{11}$ (maximum $40 \cdot 10^{11}$) polarized H^- /pulse.

LINAC

$5 \cdot 10^{11}$ polarized H^- /pulse at 200 MeV, P=85-90%

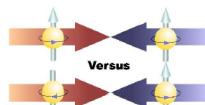
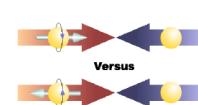
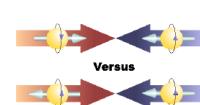
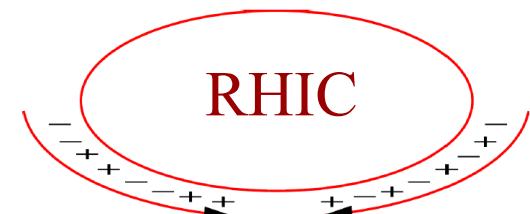
Booster

$2 \cdot 10^{11}$ protons /pulse at 2.3 GeV

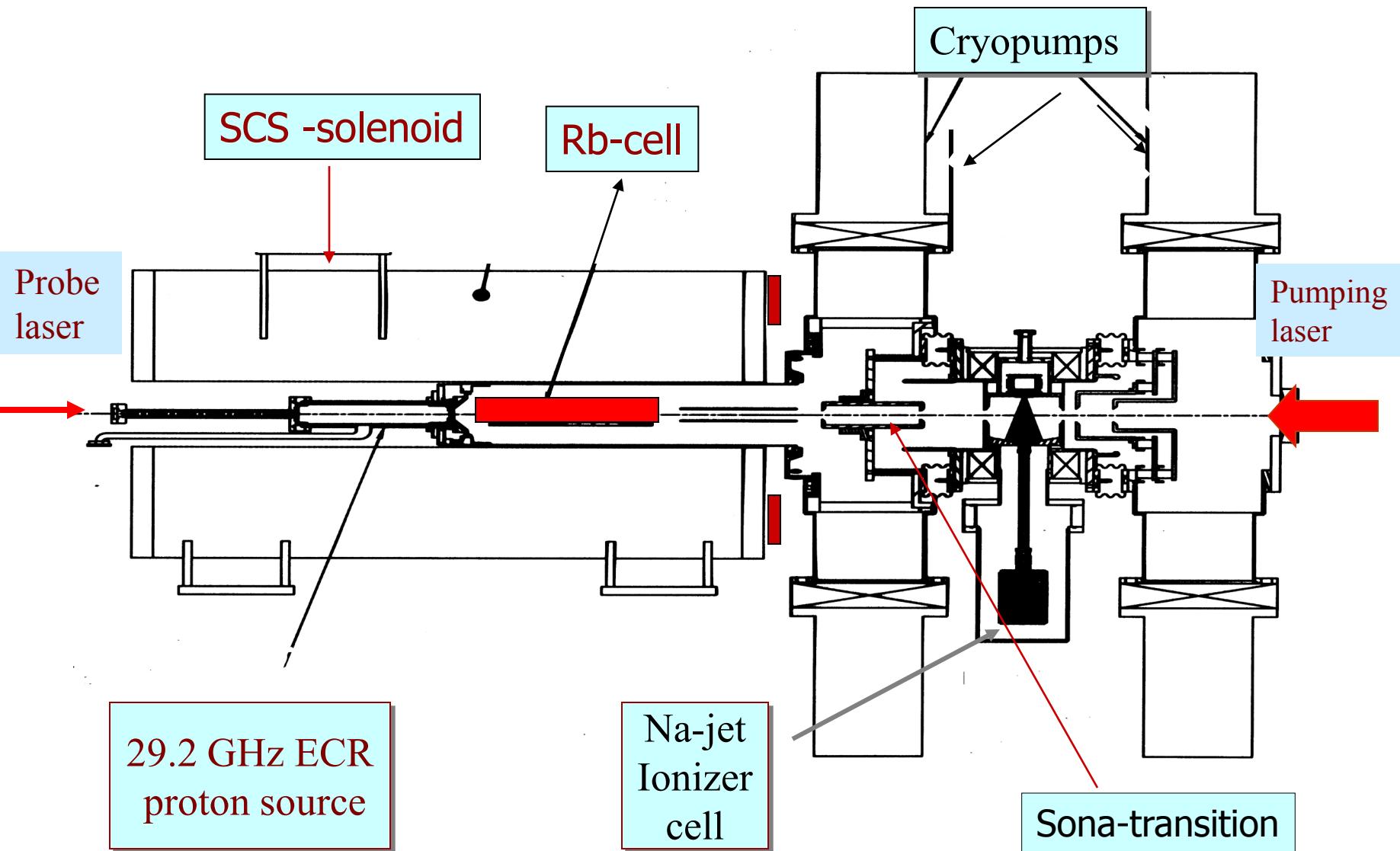
AGS

$1.7 \cdot 10^{11}$ p/bunch

$\sim 1.5 \cdot 10^{11}$ p/bunch, P~60-65% at 100 GeV
P ~ 50% at 250 GeV

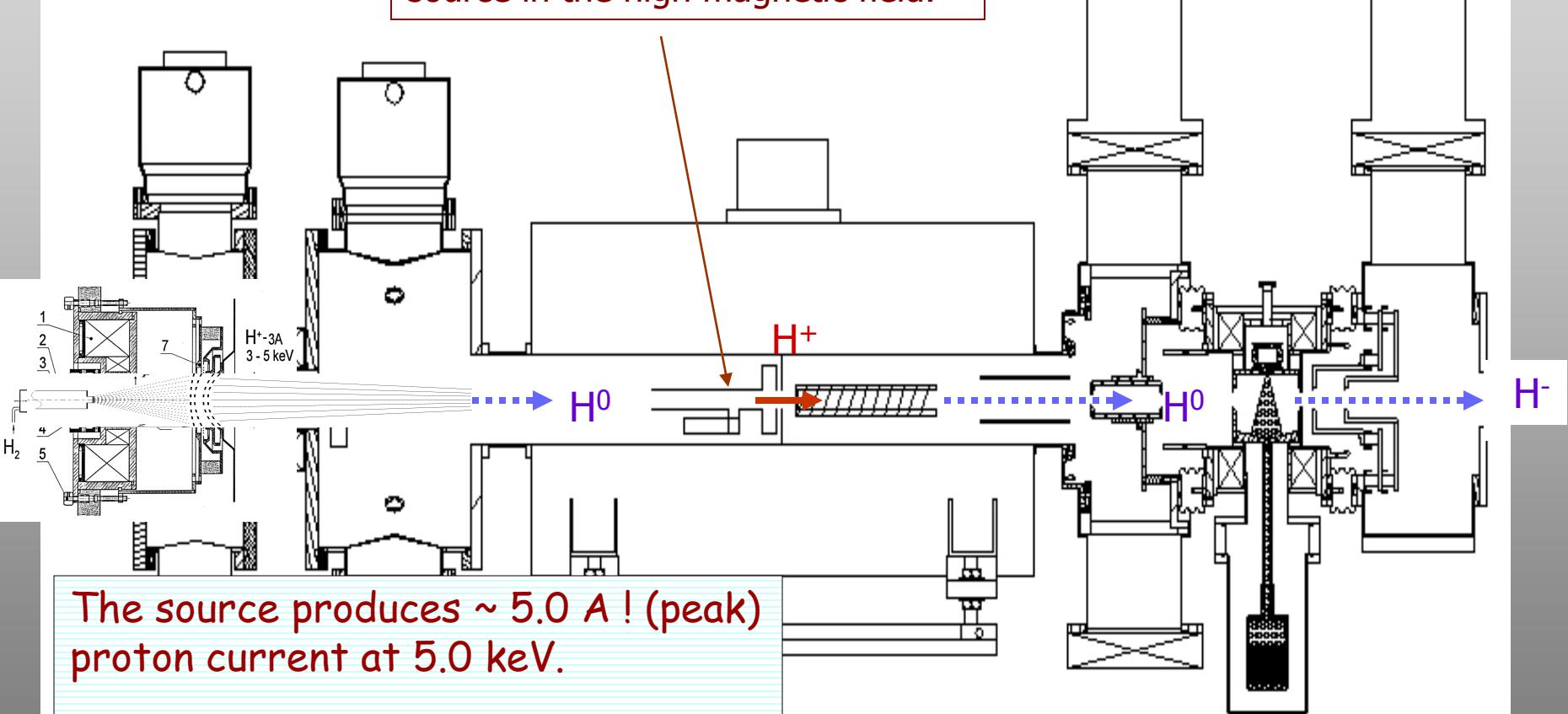


Schematic Layout of the RHIC OPPIS



OPPIS upgrade with the Fast Atomic Beam Source (FABS). The Third- Generation.

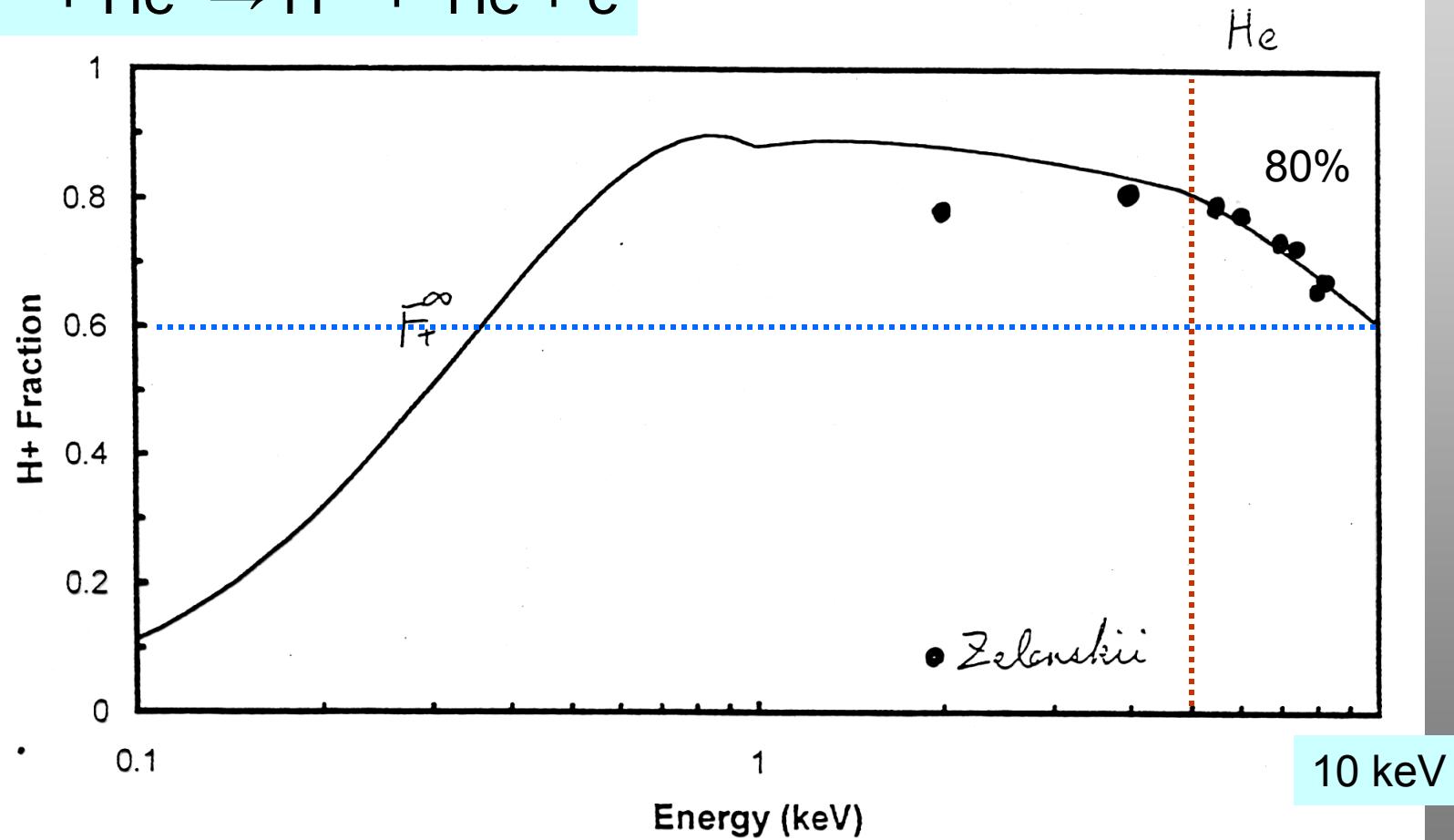
He – ionizer cell serves as a proton source in the high magnetic field.



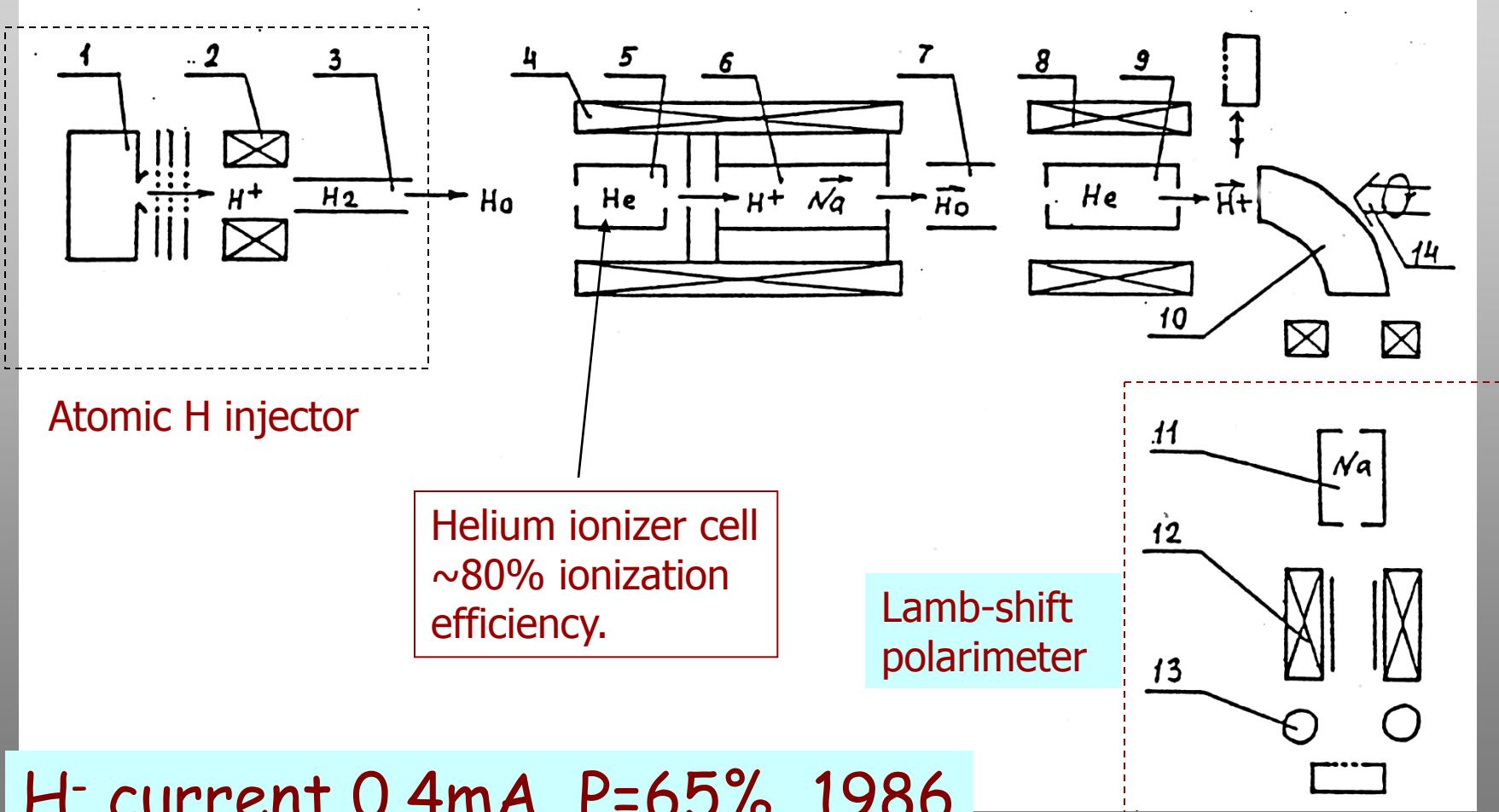
The source produces ~ 5.0 A ! (peak)
proton current at 5.0 keV.

- ~ 10 mA H⁻ current, P = 85-90%.
- ~ 300 mA (high-brightness)
unpolarized H⁻ ion current.

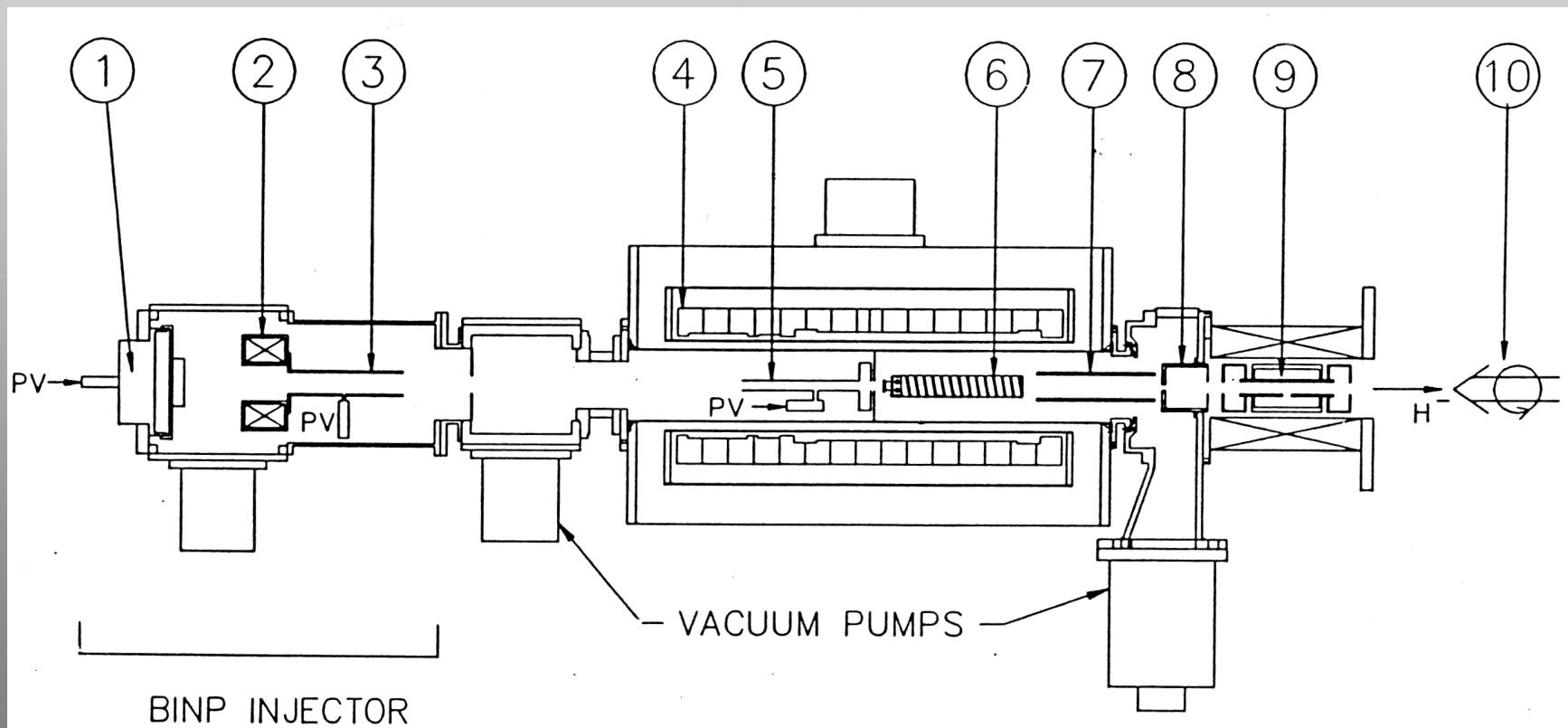
Hydrogen atomic beam ionization efficiency in the He- cell.



Pulsed OPPIS with the atomic hydrogen injector at INR, Moscow, 1982-1990. The First-Generation.



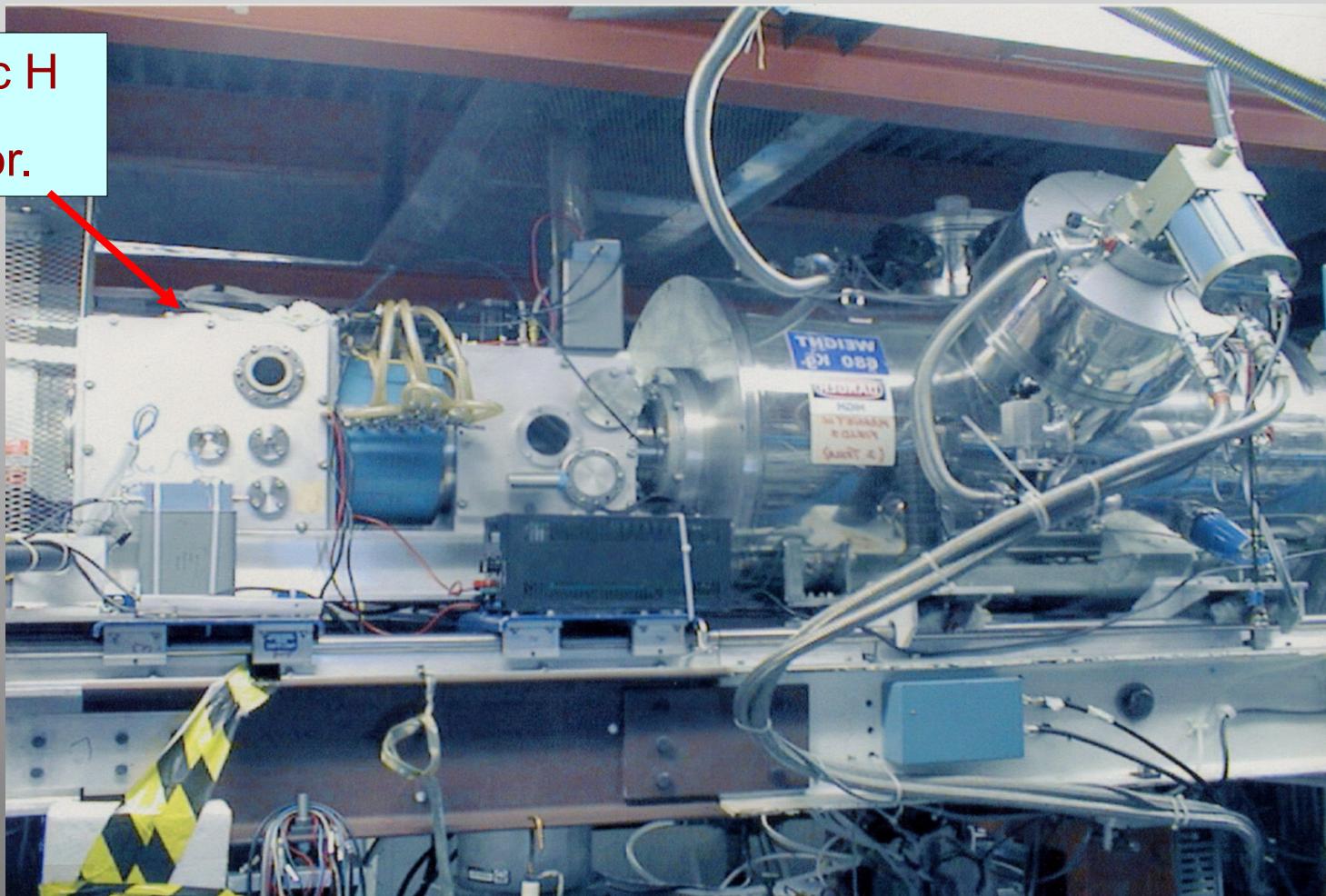
Feasibility studies with Atomic Beam Injector at TRIUMF, 1997-99. The Second Generation.



A pulsed H⁻ ion current of a 10 mA was obtained in 1999.

Pulsed OPPIS at TRIUMF, 1997-99.

Atomic H
Injector.



A pulsed H^- ion current of a 10 mA was obtained in 1999.

Small diameter beam in the FABS.

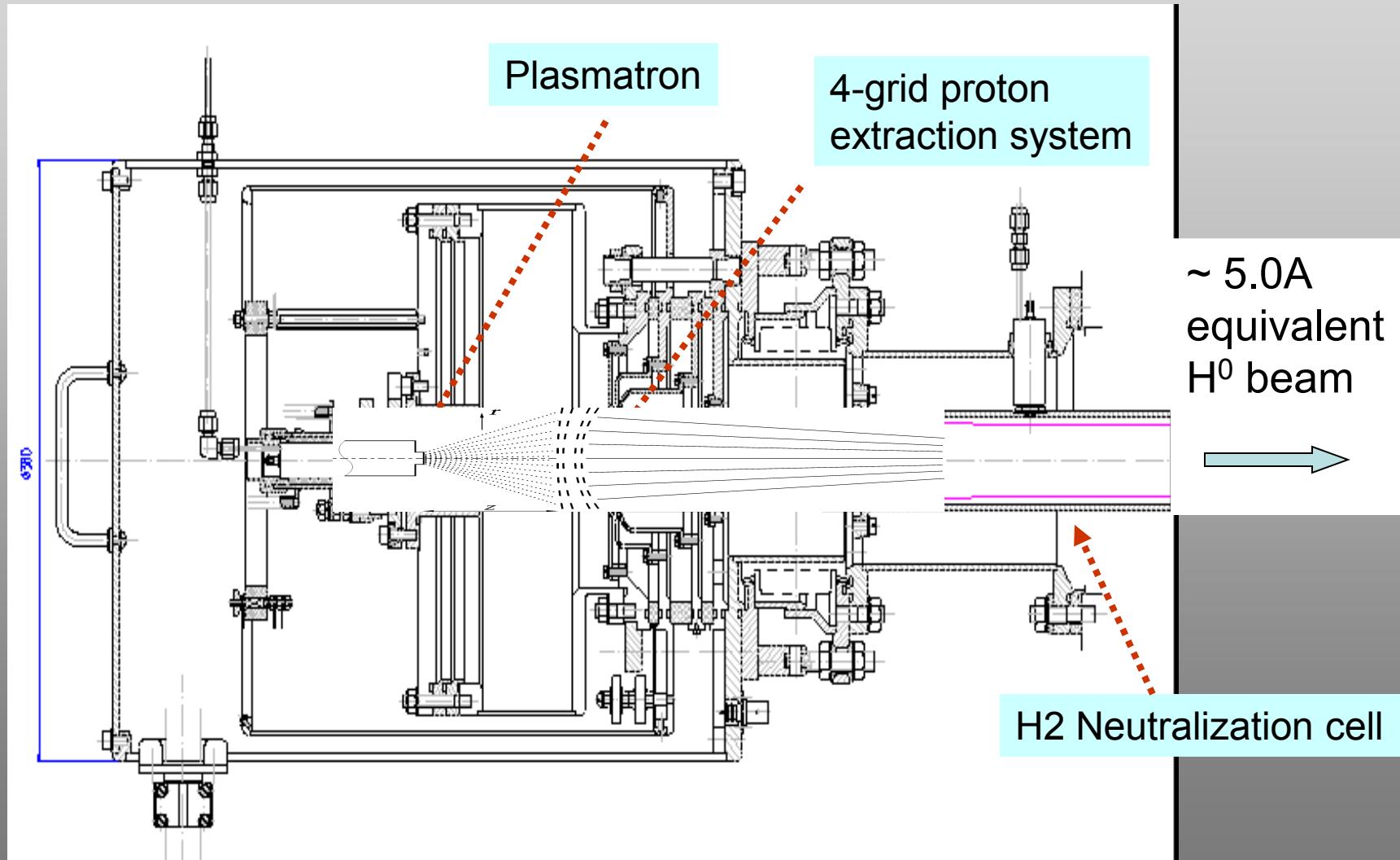
- Atomic H⁰ injector produces an order of magnitude higher brightness beam. A 5-10 mA H⁻ ion current can be obtained with the smaller, (about 15 mm in diameter) beam.
- Higher Sona-transition efficiency for the smaller beam radius.
- Smaller beam emittance : $\epsilon_n \sim B \times R^2$

The Atomic Hydrogen Injector

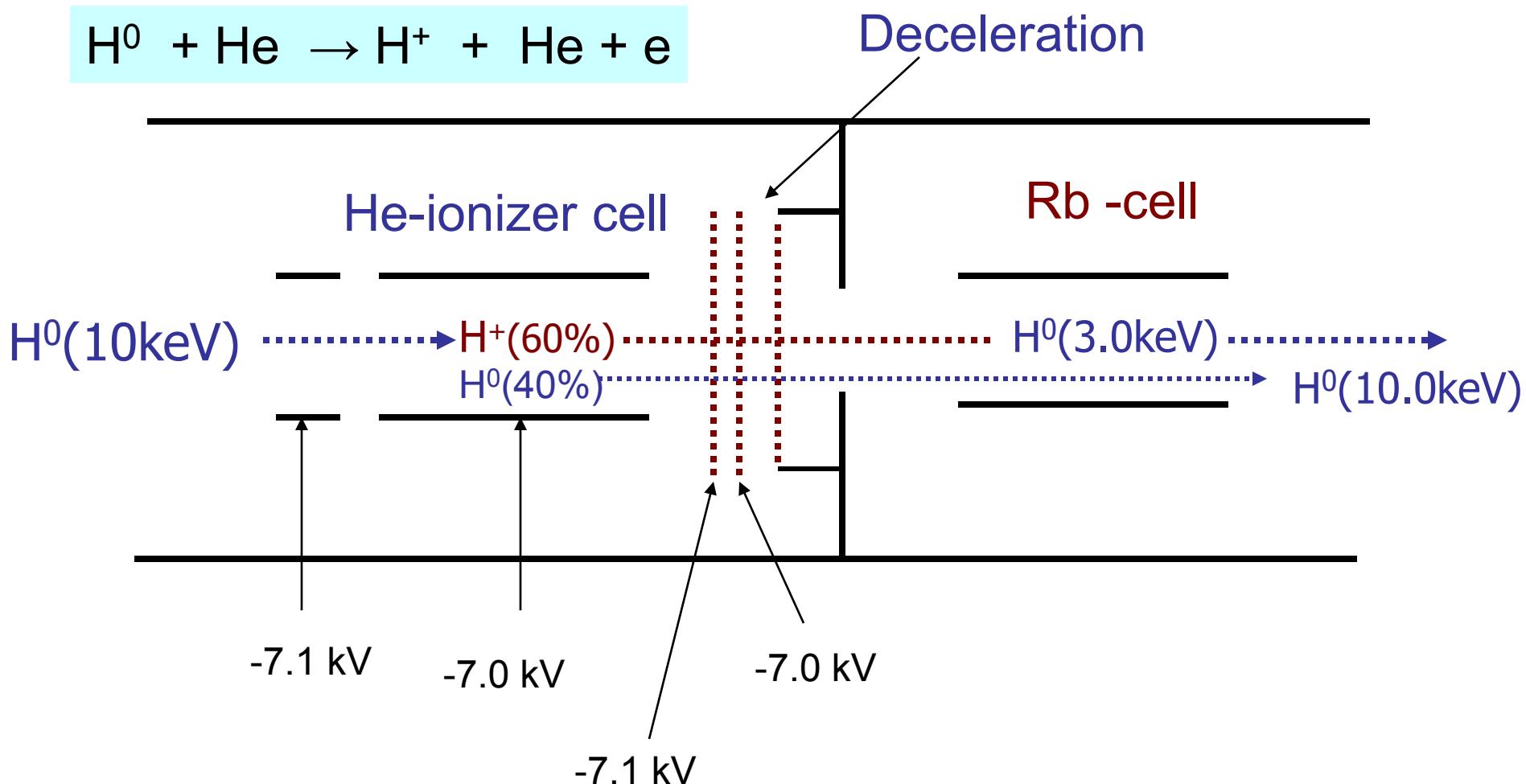
Collaboration agreement with BINP, Novosibirsk
on polarized source upgrade.

- Contract with BINP, Novosibirsk. Delivery: May, 2011.
- Two sets of sources and power supplies, local control system.
- 4- sets of spherical extraction grids (focal length ~150 cm) for polarized source.
- 2- sets of shorter focal length (~ 50cm) grids for studies of basic limitation of high-brightness H⁻ ion beam production in the charge-exchange process.

BINP design for the "Atomic Beam Injector".



Residual unpolarized H^0 beam component suppression by the energy separation.



Ratio of the target to the emitter current density vs spherical grids focal length.

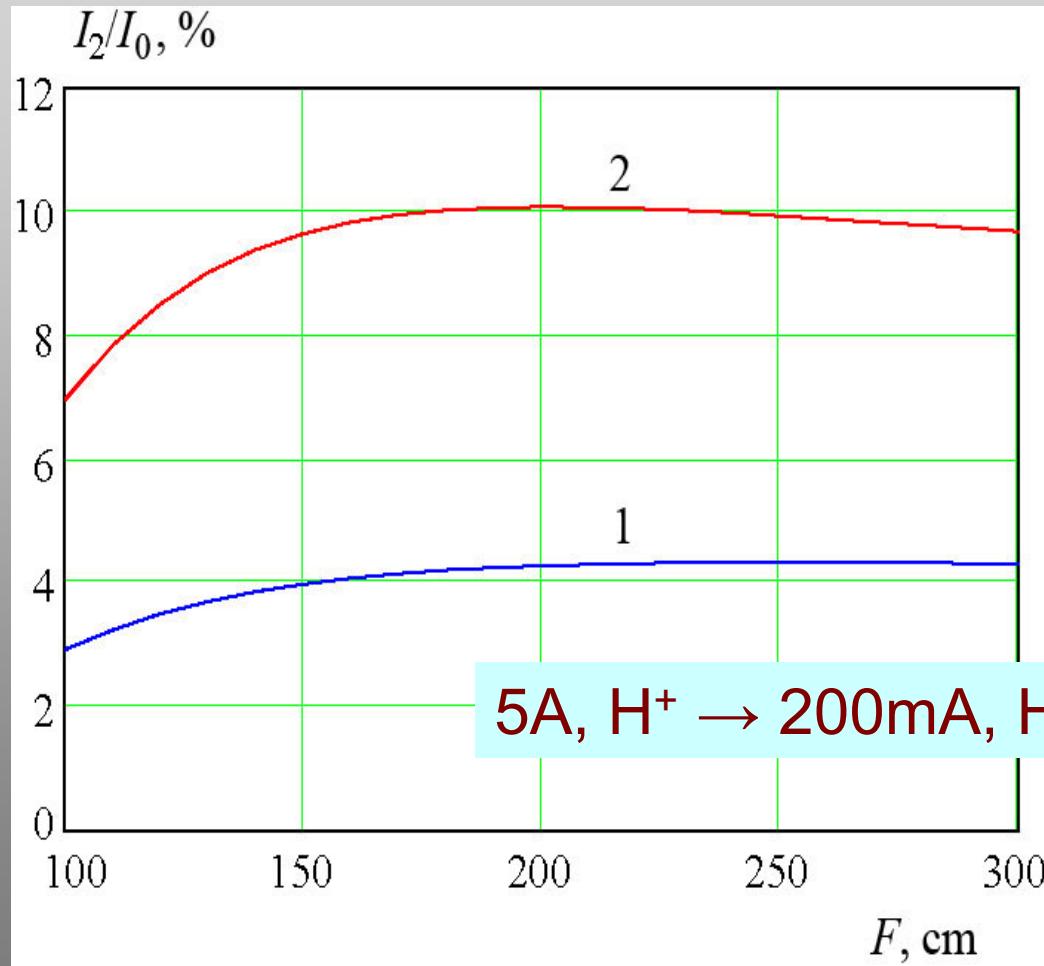
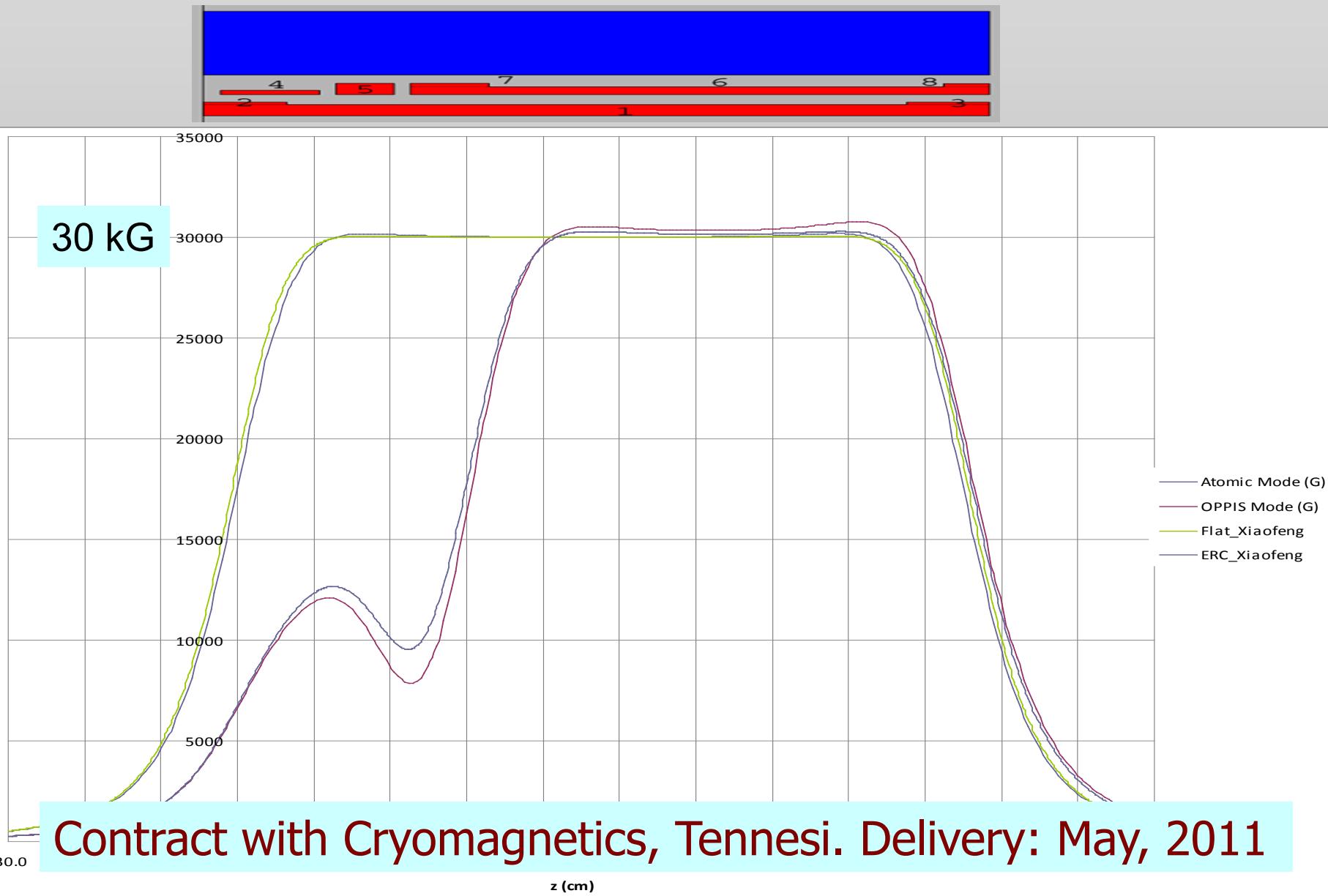


Fig. 8. Ratio of the target current to the emitter current vs focal distance:
1 – without magnetic field, 2 – with magnetic field.

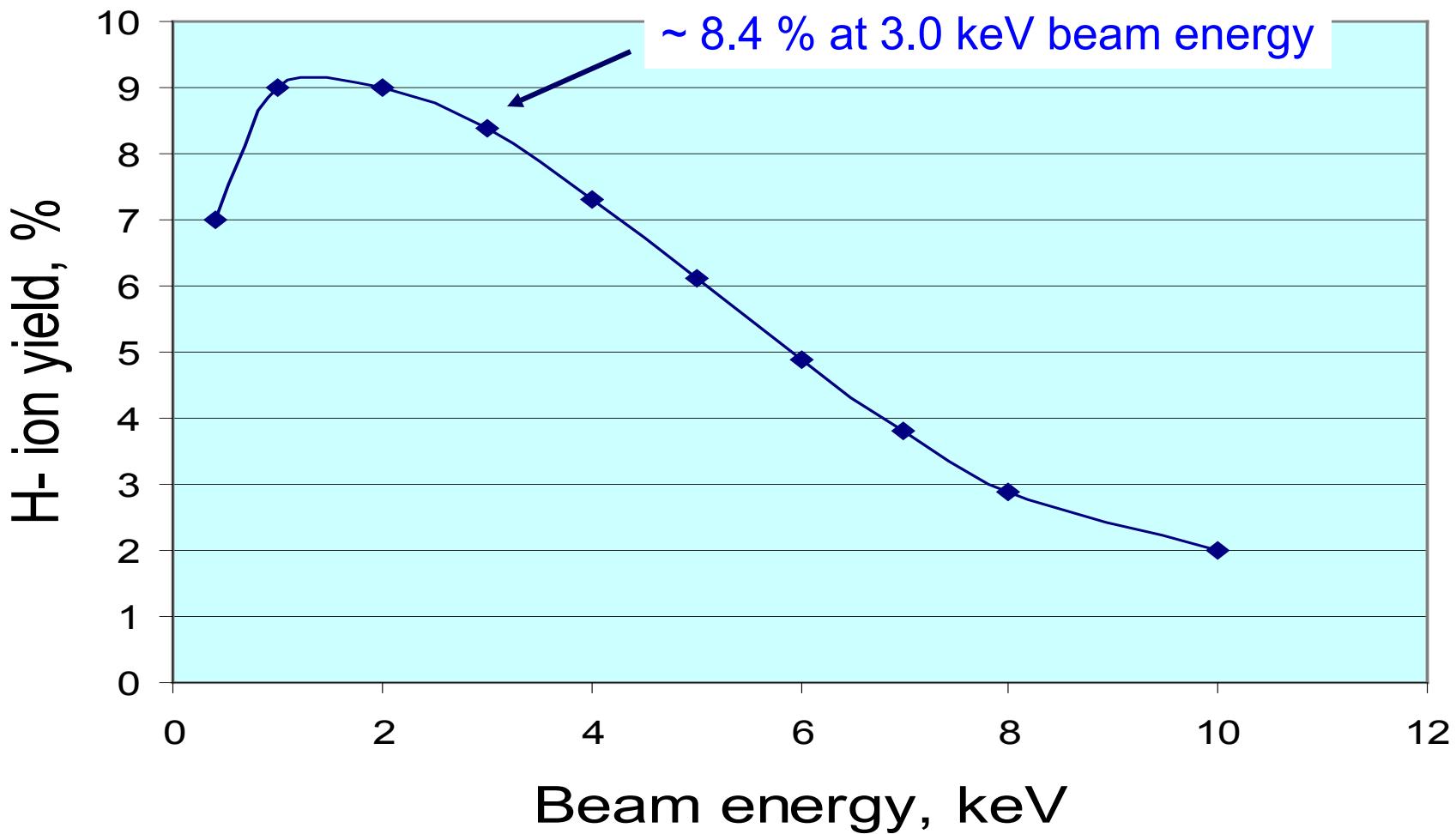
A new superconducting solenoid.

- Contract with Cryomagnetics, Tennessee.
- Delivery: May, 2011.
- Higher 30 kG field. Better field shape. Cold iron yoke.
- He- re-condenser, low maintenance cost.
- Two mode of operations. Atomic beam mode –long flattop.
- ECR- mode provides field shape for the conventional ECR-mode operation.

A new superconducting solenoid. ECR-mode.



H⁻ yield vs beam energy



Sodium-jet ionizer cell

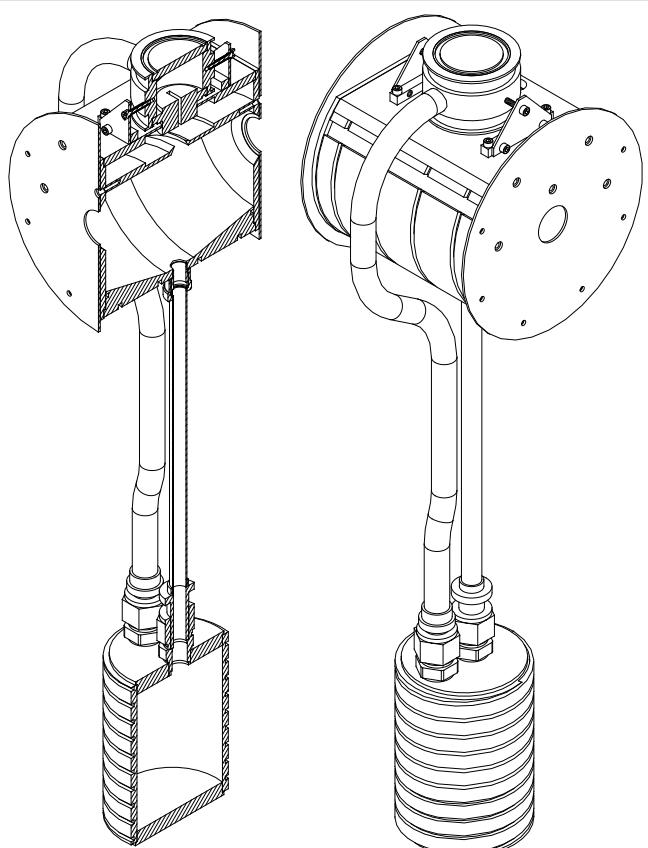
- An application of conventional “hot-pipe” sodium vapor cell for high-intensity H⁻ ion beam production in charge-exchange collisions is limited by the fast increase of the sodium losses, which are proportional: $\sim n^3 / L$, where n is vapor density and L is the cell length.

The solution is the Jet-ionizer cell.

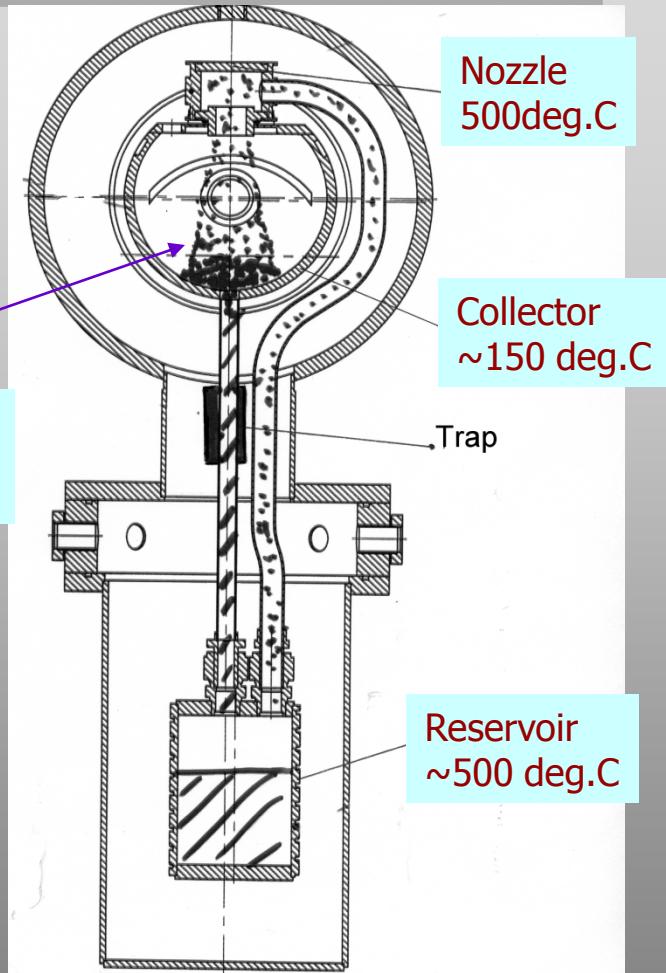
Sodium-jet ionizer cell

Transversal vapor flow in the N-jet cell.

Reduces sodium vapor losses for 3-4 orders of magnitude, which allow the cell aperture increase up to 3.0 cm .

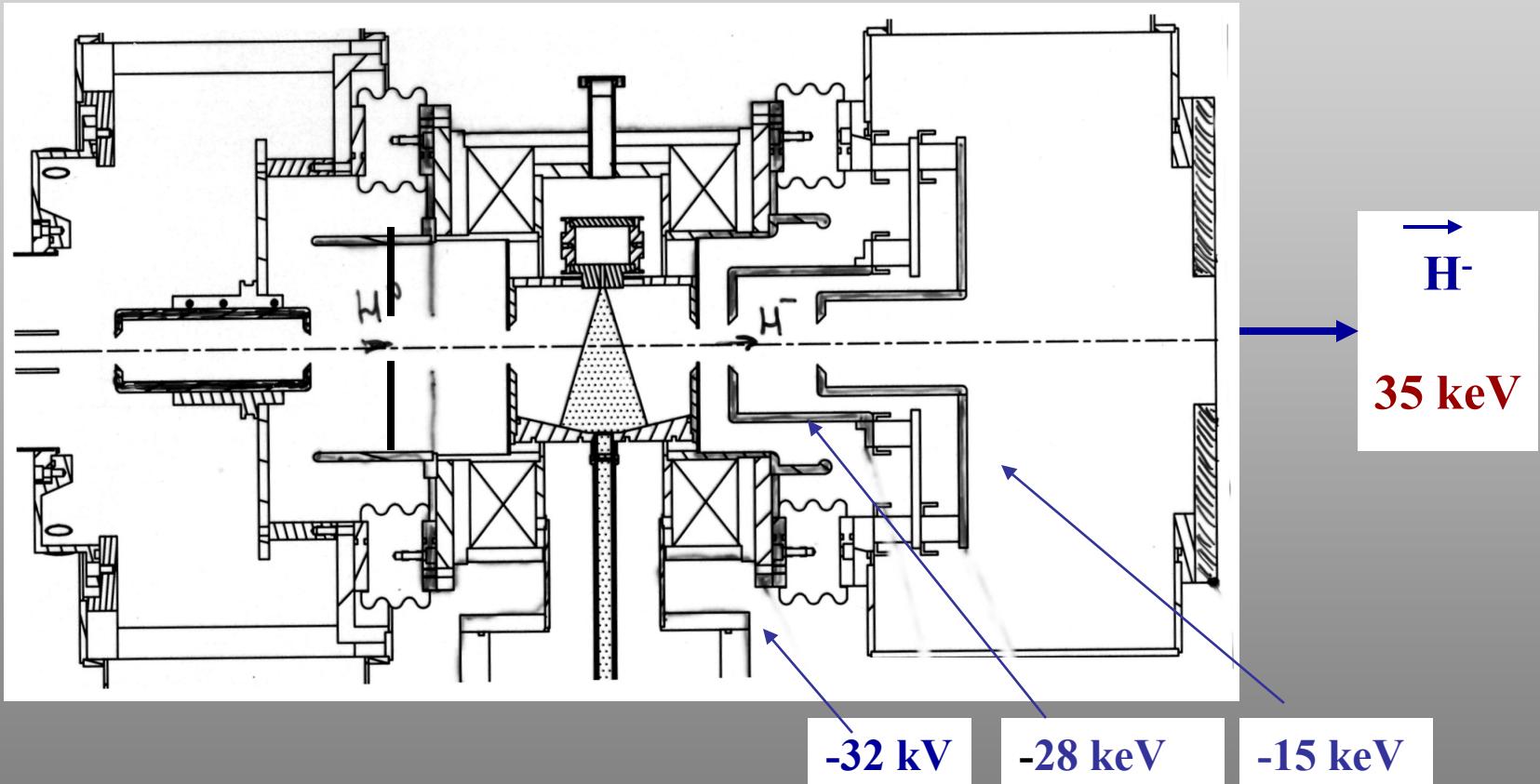


$NL \sim 2 \cdot 10^{15}$ atoms/cm²
 $L \sim 2-3$ cm



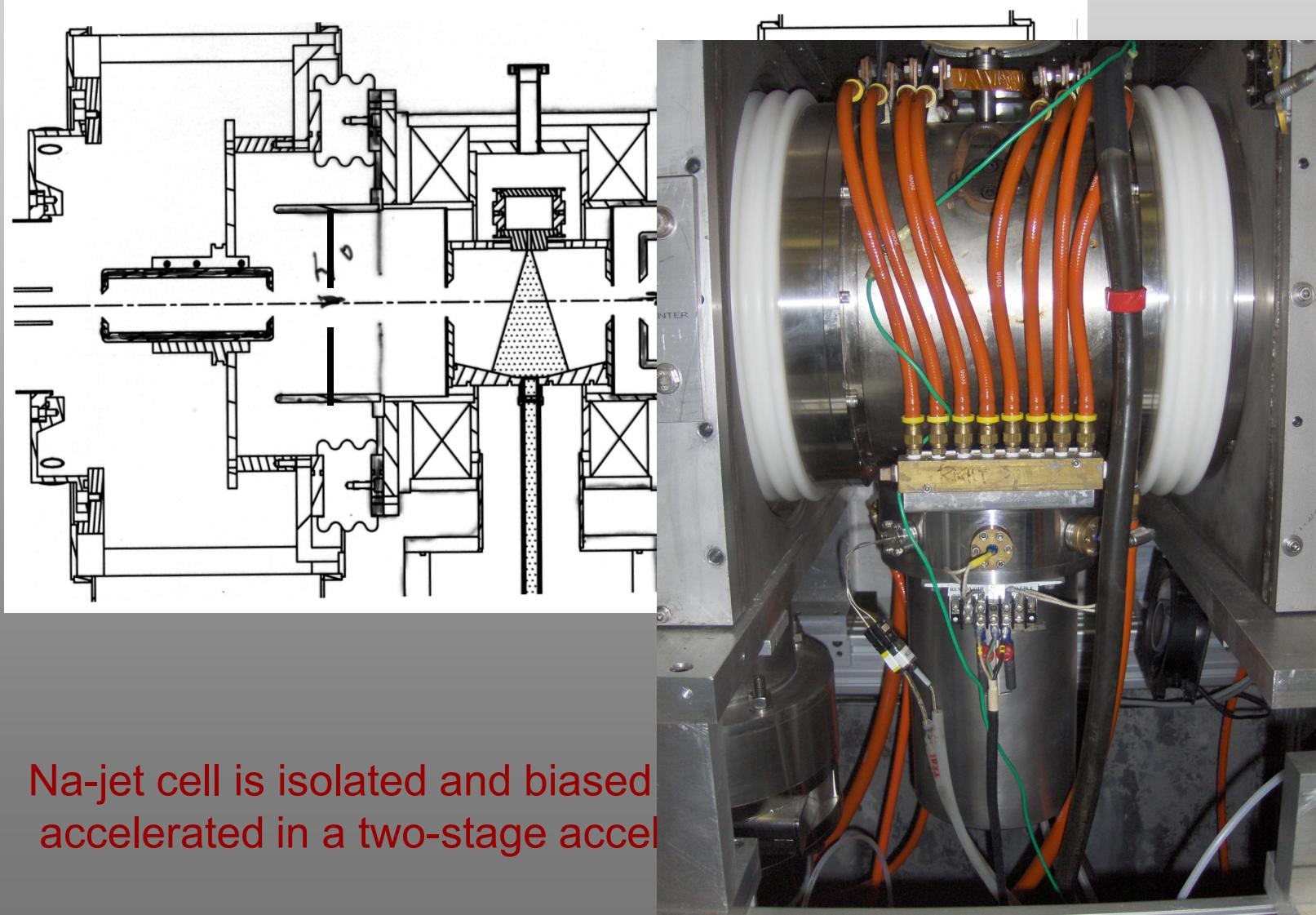
Reservoir – operational temperature. Tres. ~ 500 °C.
Nozzle – $T_n \sim 500$ °C.
Collector- Na-vapor condensation: $T_{coll.} \sim 120$ °C
Trap- return line. $T \sim 120 - 180$ °C.

H^- beam acceleration to 35 keV at the exit of Na-jet ionizer cell



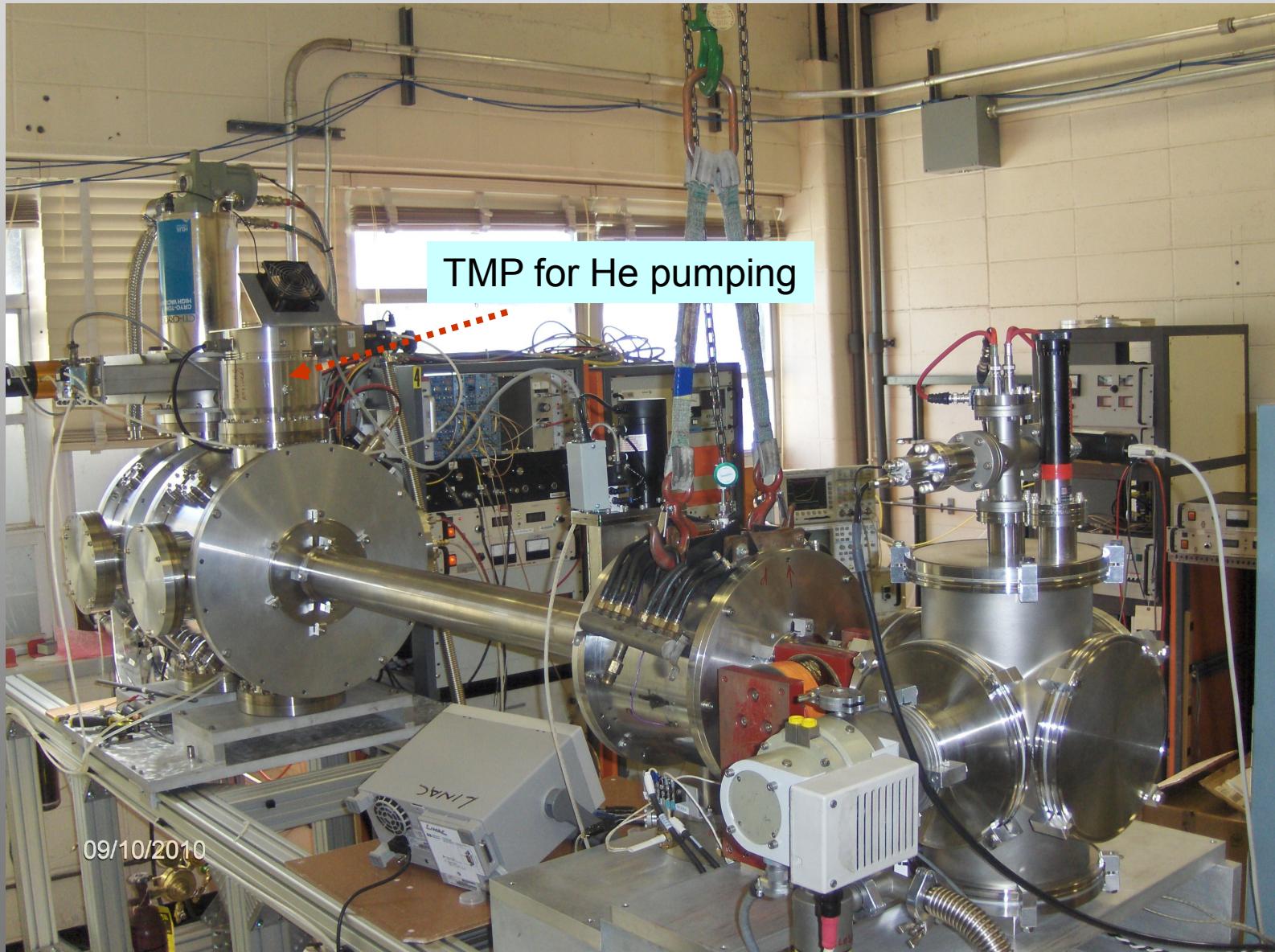
Na-jet cell is isolated and biased to – 32 keV. The H⁻ beam is accelerated in a two-stage acceleration system.

H- beam acceleration to 35 keV at the exit of Na-jet ionizer cell

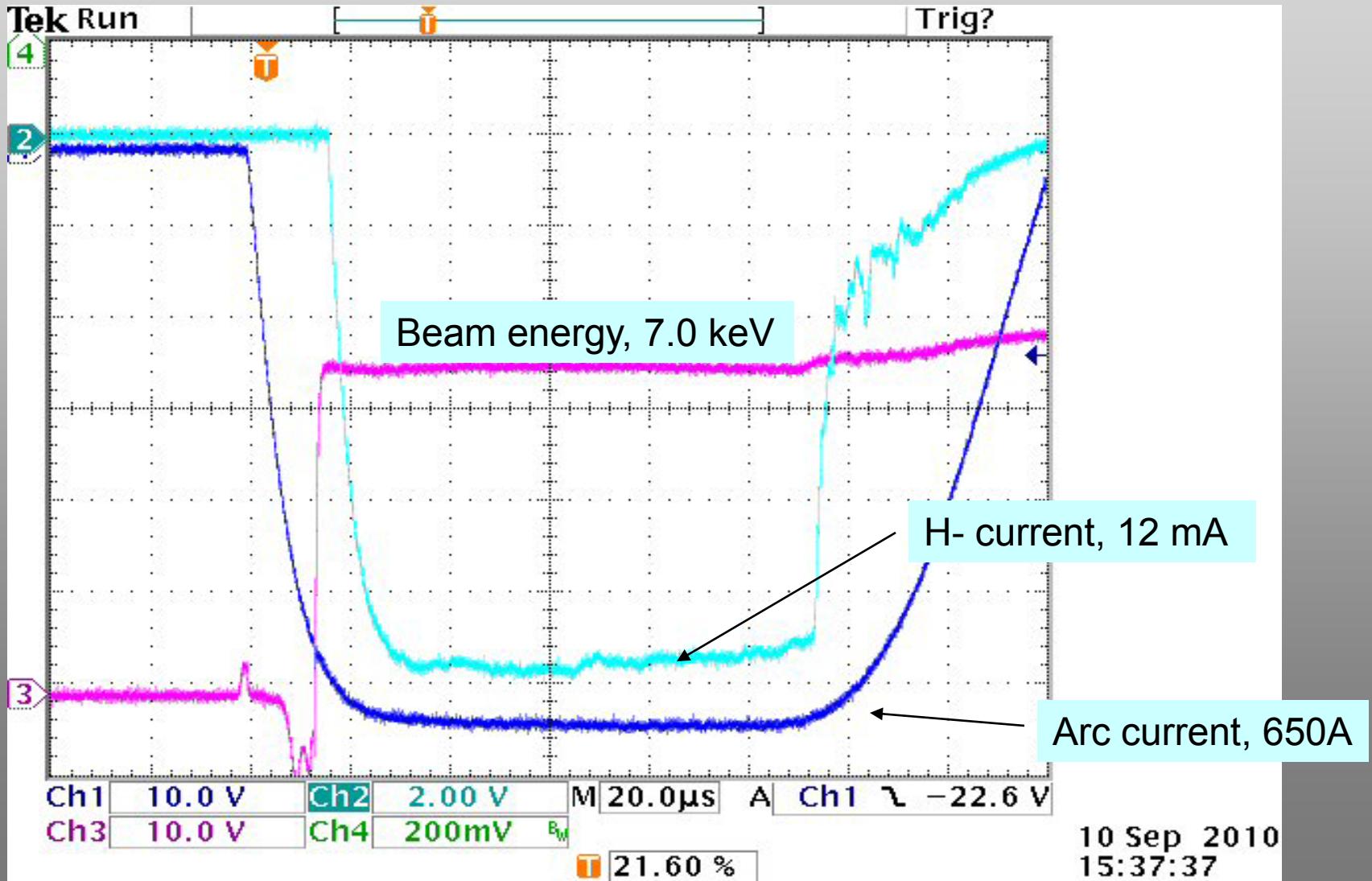


Na-jet cell is isolated and biased
accelerated in a two-stage accel

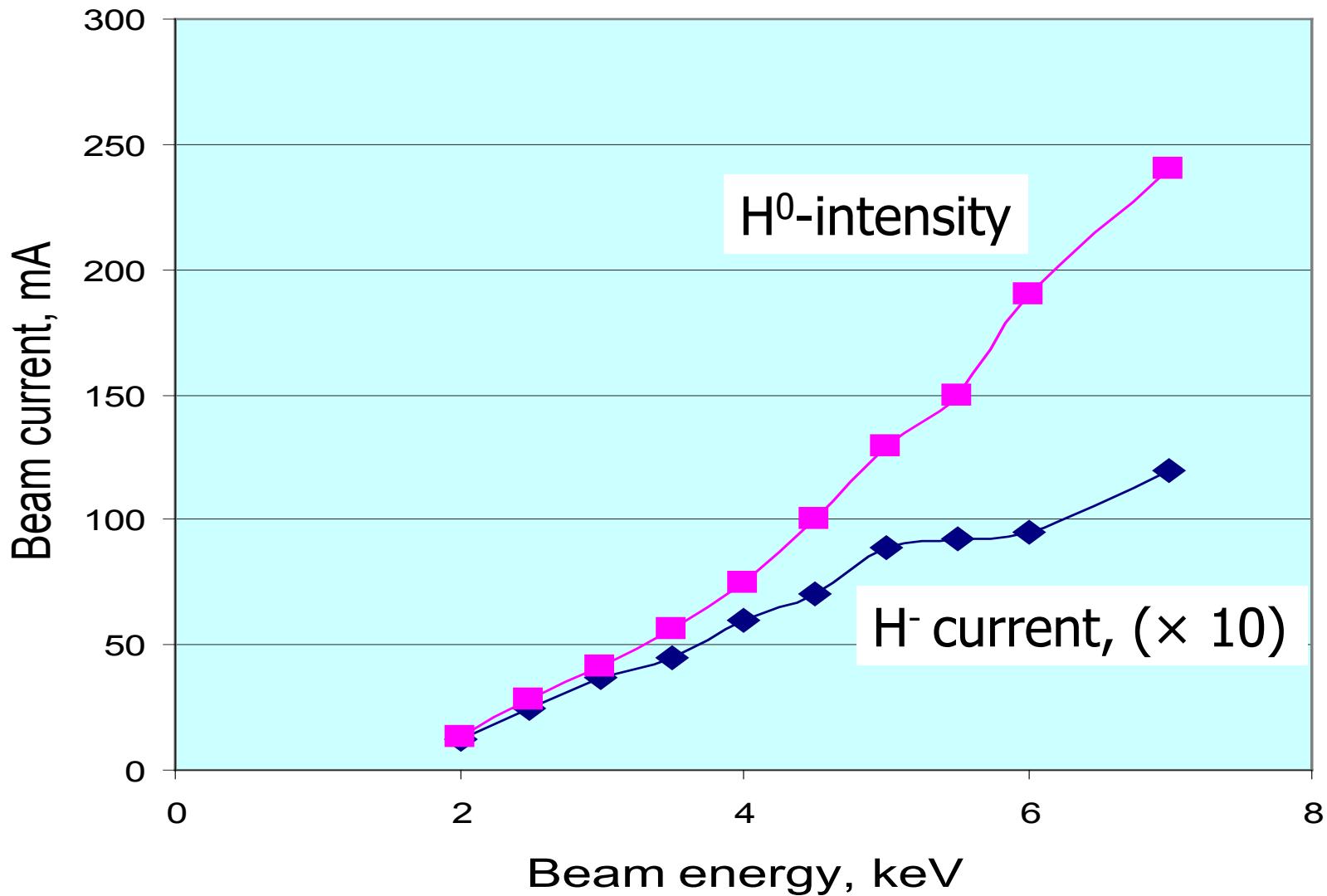
A new FABS test bench.



FABS operation



H^- ion beam current vs beam energy (within 25 mm ionizer acceptance).



Basic limitation on the intensity of H⁻ beam production in the Na-jet cell.

- According to paper: A.I.Krylov, V.V.Kuznetsov. *Fizika Plasmy*, **11**, p.1508 (1985), influence of secondary plasma on a Na-jet stable operation is determined by parameter :

$$\alpha = J\sigma_{ion} / ev_0$$

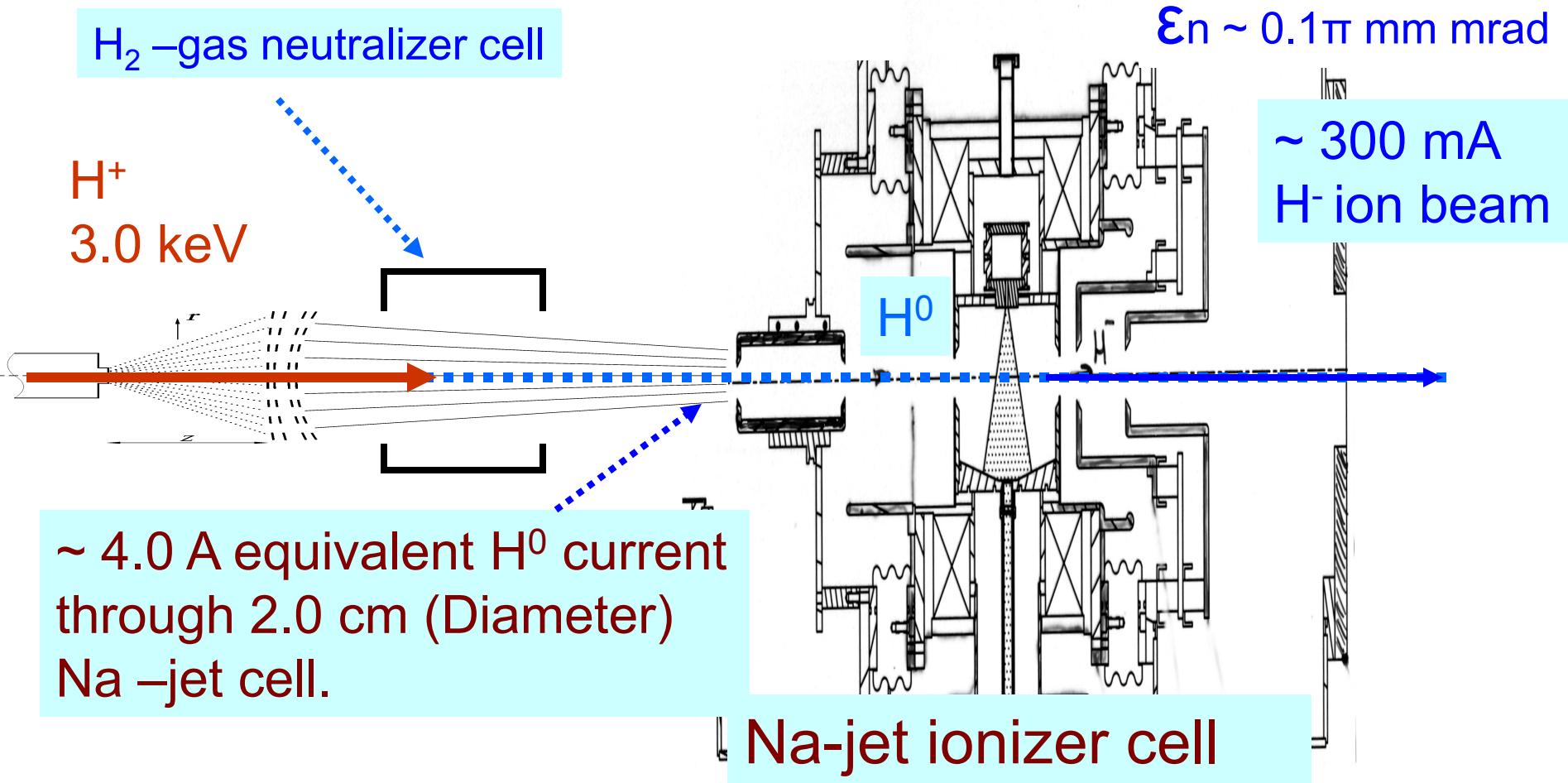
where: J - beam current (per cm) of jet-target length; σ_{ion} – cross-section of ionization of atoms of a target, v_0 – atoms velocity in the Jet.

Critical value (Jet instability) of α is ~ 0.06 .

- The cross section of charge exchange of protons on sodium atom has value of: $1.2 \cdot 10^{-14} \text{ cm}^2$.
- The electron capture cross section for hydrogen atoms in Na-jet is of: $5 \cdot 10^{-16} \text{ cm}^2$.

The separation of neutralization and H⁻ production cells should allow current density increase to: $J \sim 1.5 \text{ A/cm}^2$, without impact on the Na-jet operation.

High-brightness un-polarized H⁻ ion beam production



OPPIS upgrade with the "Fast Atomic Hydrogen Source"

- Higher polarization is expected with the fast atomic beam source due to:
 - a) elimination of neutralization in residual hydrogen;
 - b) better Sona-transition efficiency for the smaller diameter beam;
 - c) use of higher ionizer field (up to 3.0 kG), while still keeping the beam emittance below $2.0 \pi \text{ mm}\cdot\text{mrad}$, due to the smaller beam diameter.
- All these factors combined will further increase polarization in the pulsed OPPIS to *over 85%*.

Summary

- Atomic H injector produces an order of magnitude higher brightness beam than present ECR source.
- A 5-10 mA H^- ion current (50-100 mA proton current) can be obtained for the smaller (higher brightness) beam.
- The basic limitation on the production of the high-intensity (~ 300 mA), high-brightness unpolarized H^- ion beam in charge - exchange collisions will be also studied.

Primary proton beam energy (~ 10.0 keV) choice.

- Higher energy gives higher beam intensity.
- Lower ionization efficiency in the He-cell (~60%).
- Larger deceleration (~7.0 keV) after the He-cell is required.
-
- H⁻ yield reduction for 10 keV residual unpolarized H₀.
- Higher energy increases the energy separation efficiency.
- At least 10 keV energy is required for molecular H₂⁺ beam component suppression.